Tunable Diode Laser Sensors for Monitoring and Control of Harsh Combustion Environments

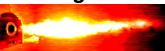
by W. Von Drasek

DOE/OIT Sensors and Controls '01

Annual Meeting New Orleans, LA June 6-7, 2001



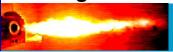




- **≻**Motivation
- **➢Project Team**
- >Technology Description
- **▶**Project Status
 - TDL Development
 - Pilot Test Platform
- **▶**Project Planning
- **▶**Budget Review

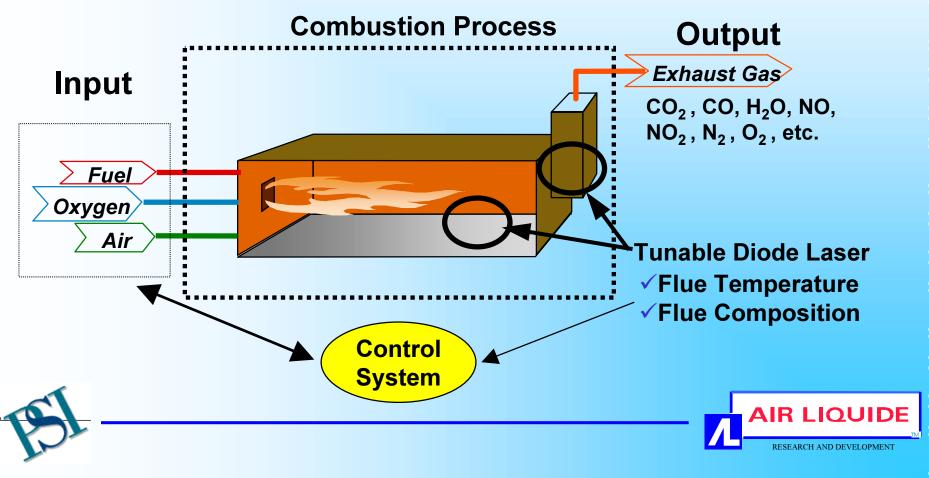


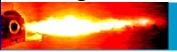




Objective

To fabricate and test an industrial multi-gas diode laser sensor system for O₂, CO, and Temperature monitoring for high temperature harsh environments.



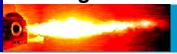


TDL Technology Advantages

- **✓** Developed around telecommunication components
 - •Near-IR diode lasers operate near room temperature
 - Fiber optic compatible
- √ Fast response time
 - •10 msec measurement time
 - Time averaged 10 Hz sampling rate
- √Simple electronic detection
 - Reduced cost
 - Compact
- ✓ Multi-functional
 - Multiple-species
 - Temperature



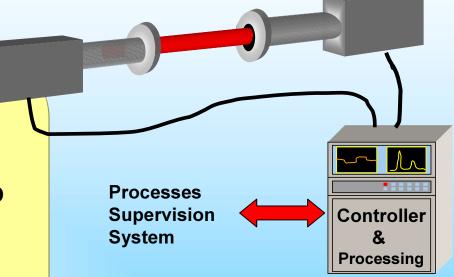




Project Objective

System Features

- √ Harsh Environment Acceptable
 - •T>1600 °C
 - High Particle densities
- ✓ Multi-species Monitoring O₂,CO, H₂O
- ✓ Multi-functional
 - Temperature
 - Air Entrainment
 - Particle Density
- **✓** Fast-Time Response 1-10 Hz
- ✓ Calibration Free
- ✓Integrate with Processes Control
- ✓ Autonomous Operation
- **✓** Cost Effective

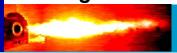


Beam Transport and Collection

System Ready for Testing Sept.-Nov. 2001

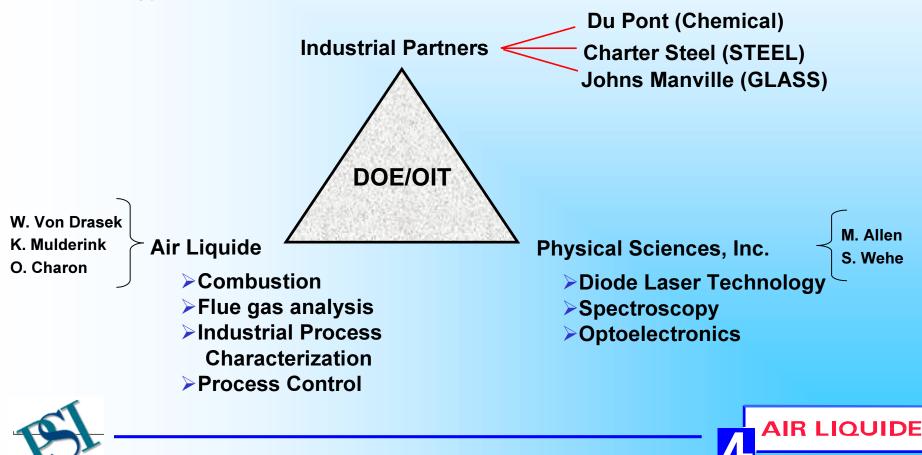






Project Team

To address the technical issues associated with traditional monitoring techniques Air Liquide and Physical Sciences, Inc. formed a project team for the development of an *Advanced Sensor* utilizing *Tunable Diode Laser Technology*.





IOF Partners and Applications

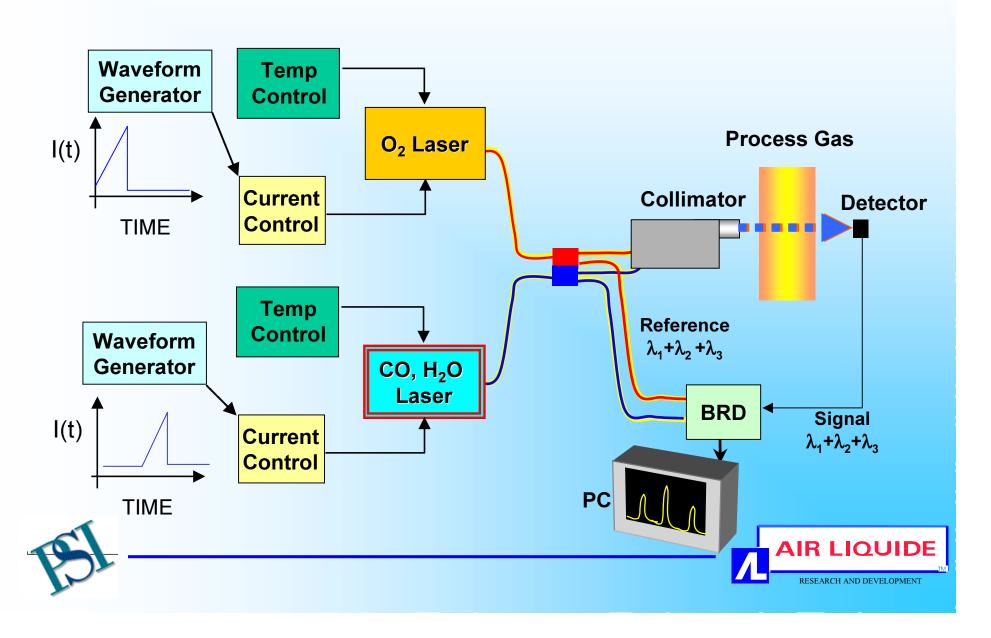
Industry	Partner	Application	
GLASS	Johns Manville	Fiber Glass Melting Tank •Energy Efficiency •NOx Reduction	
CHEMICAL	Du Pont	Sulfuric Acid Recovery •O ₂ Optimization •NOx Minimization	
STEEL	Charter Steel	Reheat Furnace •Energy Efficiency •Scale Reduction	EAF Furnace •Energy Efficiency •Carbon Balance







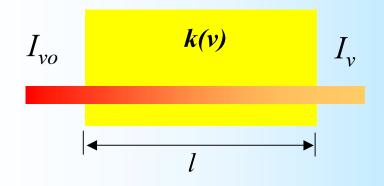
Multi-species Measurement Strategy



Resonant absorption described by the Beer-Lambert Relation:

$$I_{v} = I_{v,o} \exp\left[-S(T)g(v - v_{o})Nl\right]$$

Linestrength Lineshape Number Density X Pathlength

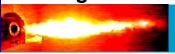


Number Density

$$N = \frac{1}{S(T)l} \int \ln \left(\frac{I_{vo}}{I_{v}} \right) dv$$







Technology Development Considerations

Two Separate Technology Development Issues ① Beam Transport and Collection ✓ Mutiplex Beam Interface ✓ Demultiplexed ✓ Radiation Rejection ✓ Noise suppression **PROCESS** Controller **Processing** Laser System **✓** Control Circuitry **Processes** ✓ Signal Circuit (BRD) **Supervision** ✓ Multiple Laser Integration **System**



Technology Developed in DoE Program

Multi-parameter Sensor system

- O₂

-CO

 $-H_2O$

-Temperature

Evaluation on a Diverse
Range of Industrial Processes

- BRD Industrial Testing
 - -Cost effective
 - -Reduce system complexity
- HT Spectroscopy







700 kW Oxy-Fuel Pilot Furnace



Oxy-Fuel or Air-Fuel

Combustion Chamber Characteristics

Dimensions: 4.0 m x 1.0 m x 1.0 m

Firing Rate: Up to 720 kW (varying load)

Operating Temperature: Up to 3000°F (1650°C)

Heat-up rate: Up to 500 °C/h

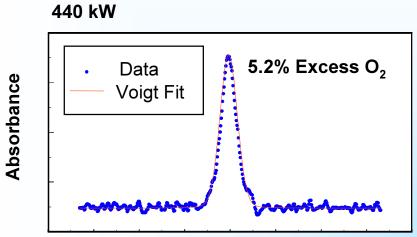
PLC and PC Supervision Controls:

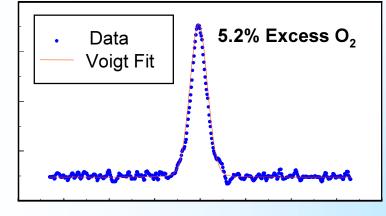
(Real Time Heat and Mass Balance)

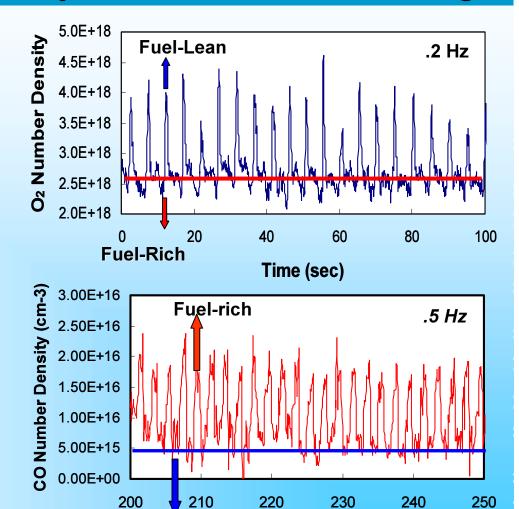




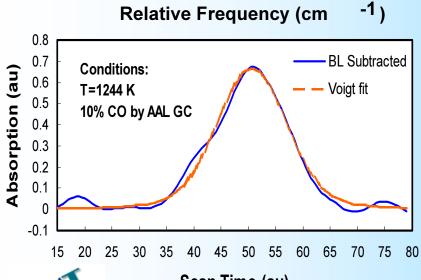
Dynamic Process Monitoring







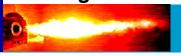
Fuel-lean



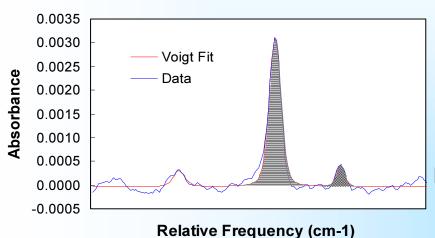




Time (sec)



Temperature Measurement



O₂ lineshape at 1540 K, 100 cm path

Temperature

$$R = \left(\frac{S_1}{S_2}\right)_{T_o} \times \exp\left[\frac{-hc\Delta E}{k}\left(\frac{1}{T} - \frac{1}{T_o}\right)\right]$$

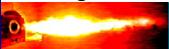
Ratio of integrated absorbance for two transitions

Sample	TDL	ST	% Error
1	1756	1702	3.17274
3	1632	1613	1.17793
2	1477	1540	-4.0909

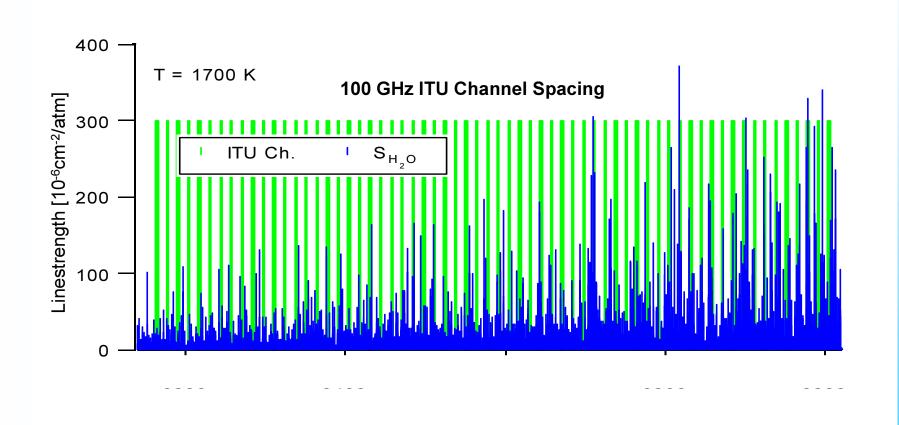
•Ref. T= 1495 K







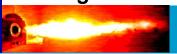
LINE SELECTION PROCESS



Over 28000 Lines Accessible!







Selection Process Criteria

H₂O Present at High Concentration Levels in all Combustion Processes

- Line Selection Process (HITEMP)
 - ✓ Optimum Energy Separation, $\Delta E'' = 2T \frac{k}{k_0}$
 - ✓ Minimum Linestrength Required, S_{min}
 - √ Spectrally Isolated
 - ✓ Spectrally accessible (1.5 µm)
 - √ Validation Required (Experimental)

Two Pair of H₂O lines Best Solution

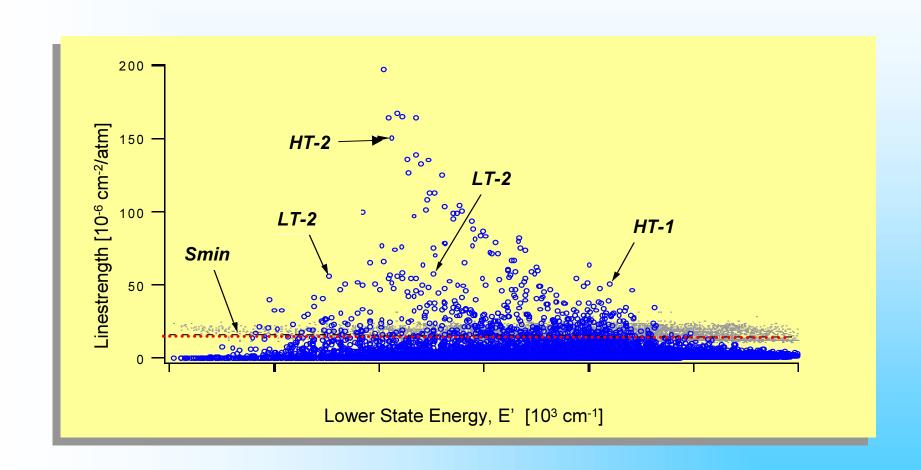
LT→ Low Temp HT→ High Temp







Theoretical HITRAN Selection

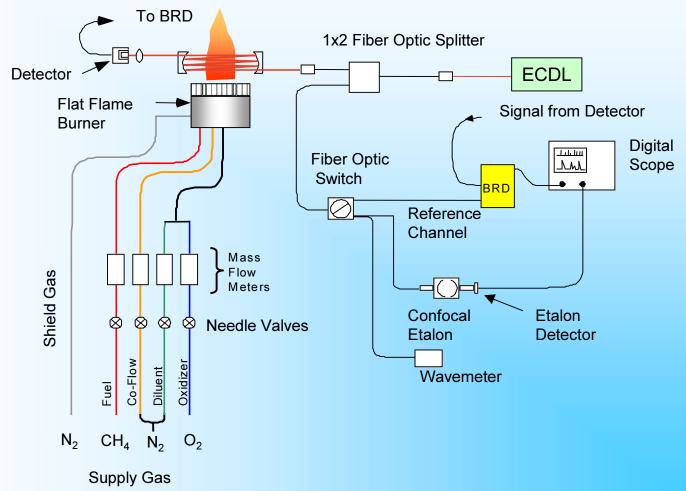






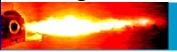
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LABORTORY SETUP









Spectral Survey Summary

Empirical Line Selection

- 25 lines examined
 - √Yield 300 possible line pairs
- 7 lines Identified
 - **√**Good SNR
 - ✓No Interference
 - ✓ Low Temp pair ± 15 K
 - √High Temp pair ± 35 K
 - ✓ Near Isolated CO line

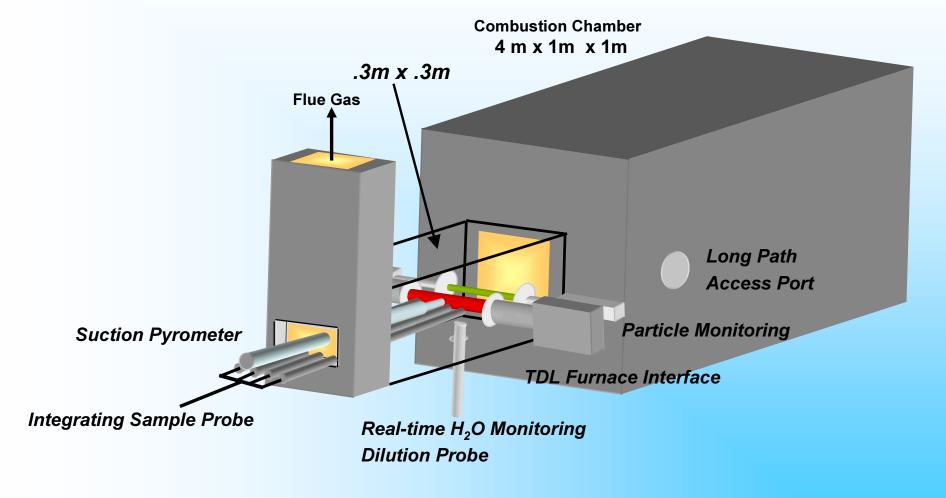
Laser Selection Completed







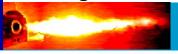
FLUE GAS CHARACTERIZATION



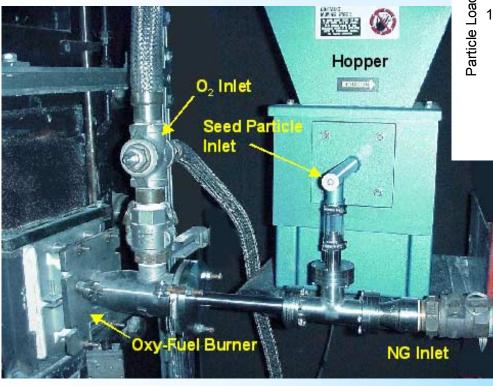


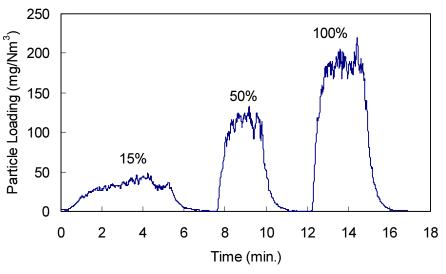


Chicago Research Center



Dirty Process Gas Simulator





Seed Particles

>Al₂O₃

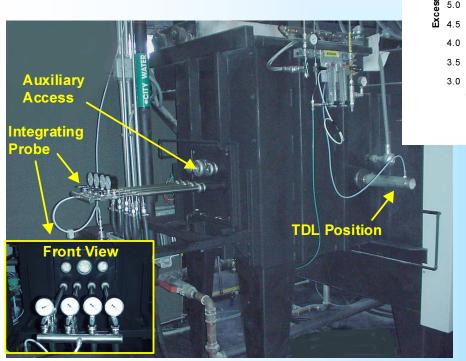
>ZrO₂

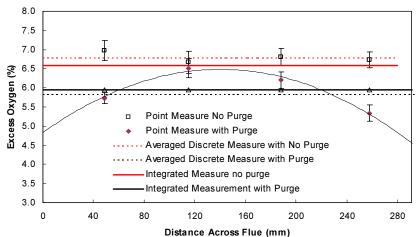


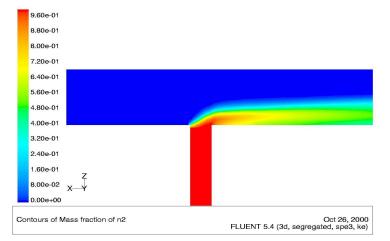




Integration Sampling Probe





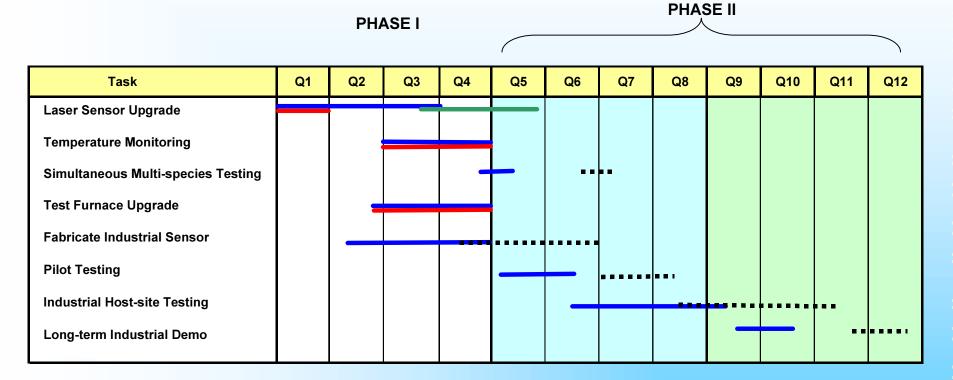








Milestone Status



Planned
Completed
Extended
Shifted





Project Budget Status

